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In re application of

Yukiko NISHIOKA et al.

Confirmation No. 6378

Serial No. 10/536,961

Mail Stop: OFFICE OF INITIAL PATENT EXAMINATION'S FILING

RECEIPT CORRECTIONS

Filed May 31, 2005

Attorney Docket No. 2005-0880A

SUBSTRATE CLEANING APPARATUS AND METHOD

### REQUEST FOR CORRECTED FILING RECEIPT

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450 THE COMMISSIONER IS AUTHORIZED TO CHARGE ANY DEFICIENCY IN THE FEES FOR THIS PAPER TO DEPOSIT ACCOUNT NO. 23-0975

Sir:

A corrected filing receipt is requested in the above-referenced case. A copy of the original filing receipt is enclosed, with the changes noted thereon.

Expedited issuance of the corrected filing receipt is respectfully requested.

Respectfully submitted,

Yukiko NISHIQKA et al.

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Attorney for Applicants

NEP/krg Washington, D.C. 20006-1021 Telephone (202) 721-8200 Facsimile (202) 721-8250 August 15, 2005



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513 WENDEROTH, LIND & PONACK, L.L.P. 2033 K STREET N. W. SUITE 800 WASHINGTON, DC 20006-1021

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**CONFIRMATION NO. 6378** 

FILING RECEIPT

Date Mailed: 07/29/2005

Receipt is acknowledged of this regular Patent Application. It will be considered in its order and you will be notified as to the results of the examination. Be sure to provide the U.S. APPLICATION NUMBER, FILING DATE, NAME OF APPLICANT, and TITLE OF INVENTION when inquiring about this application. Fees transmitted by check or draft are subject to collection. Please verify the accuracy of the data presented on this receipt. If an error is noted on this Filing Receipt, please mail to the Commissioner for Patents P.O. Box 1450 Alexandria Va 22313-1450. Please provide a copy of this Filing Receipt with the changes noted thereon. If you received a "Notice to File Missing Parts" for this application, please submit any corrections to this Filing Receipt with your reply to the Notice. When the USPTO processes the reply to the Notice, the USPTO will generate another Filing Receipt incorporating the requested corrections (if appropriate).

Applicant(s)

Yukiko Nishioka, Tokyo, SERMANY; Koji Ato, Tokyo, JAPAN; Ryosuke Yonekura, Ebina-shi, JAPAN; Yoshikazu Ariga, Fujisawa-shi, JAPAN;

Power of Attorney: The patent practitioners associated with Customer Number 513.

Domestic Priority data as claimed by applicant

This application is a 371 of PCT/JP04/07560 05/26/2004

**Foreign Applications** 

JAPAN 2003-154642 05/30/2003

**Projected Publication Date: 11/03/2005** 

Non-Publication Request: No

Early Publication Request: No

Title

Substrate cleaning apparatus and method

### **Preliminary Class**

134

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